

PATENT
5298-06900/PM01027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Schwarz

Serial No. 10/074,888

Filed: February 13, 2002

For: REDUCING DEFECT FORMATION
WITHIN AN ETCHED
SEMICONDUCTOR TOPOGRAPHY

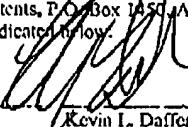
§ Group Art Unit: 1765
§ Examiner: Deo, D.

§ Atty. Dkt. No. 5298-06900

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I hereby certify that this correspondence is being transmitted via facsimile or deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313, on the date indicated below.

08/02/2005
Date


Kevin L. Daffer

AMENDMENT; RESPONSE TO OFFICE ACTION DATED MAY 2, 2005

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir/ Madam:

This paper is submitted in response to the Office Action dated May 2, 2005 to further highlight reasons why the application is in condition for allowance.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.